

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.	:	10/595,660	Confirmation No. 4264
Applicant	:	Yuichiro Shindo	
371 Filed	:	May 3, 2006	
Art Unit	:	1733	
Examiner	:	Jessee Randall Roe	
Customer No.	:	00270	
Title	:	HIGH PURITY HAFNIUM, TARGET AND THIN FILM COMPRISING SAID HIGH PURITY HAFNIUM, AND METHOD FOR PRODUCING HIGH PURITY HAFNIUM	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

This is a Response timely submitted to a non-final Office Action dated July 27, 2011.

Remarks/Arguments begin on page 2 of this paper.